



IRW

PATENT
Attorney Docket No.: SAM-0554
Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Seung-hwan Lee, *et al.*
Serial No.: 10/823,420
Filing Date: April 13, 2004
Title: METHOD OF FABRICATING A MOS TRANSISTOR WITH ELEVATED
SOURCE/DRAIN STRUCTURE USING A SELECTIVE EPITAXIAL
GROWTH PROCESS (As Amended)

Examiner: Huynh, Andy
Group Art Unit: 2818

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

10-28-05

Date

Vanessa Marakas
Vanessa Marakas

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

1. Amendment A in response to Office Action mailed on August 9, 2005;
2. Amendment Transmittal; and
3. Return Postcard.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: October 28, 2005
Mills & Onello LLP
Eleven Beacon Street, Suite 605
Boston, MA 02108
Telephone: (617) 994-4900
Facsimile: (617) 742-7774
J:\SAM\0554\amenda\transamendmenta.wpd

Anthony P. Onello, Jr.
Anthony P. Onello, Jr.
Registration Number 38,572
Attorney for Applicant



Attorney Docket No.: SAM-0554
Application Serial No.: 10/823,420
Reply to Office Action of: August 9, 2005
Amendment Dated: October 28, 2005

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Seung-hwan Lee, *et al.* Examiner: Huynh, Andy
Serial No.: 10/823,420 Group Art Unit: 2818
Filing Date: April 13, 2004
Title: METHOD OF FABRICATING A MOS TRANSISTOR WITH ELEVATED
SOURCE/DRAIN STRUCTURE USING A SELECTIVE EPITAXIAL
GROWTH PROCESS (As Amended)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail on the date indicated below in an envelope addresses to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

10-28-05

Date

Vanessa Marakas

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT A

Sir:

The following is in response to the Office Action dated August 9, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.